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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of

Oh-Nam KWON ✓

Group Art Unit: 2823

Application No.: 09/709,483 ✓

Examiner: T. Pham ✓

Filed: November 13, 2000 ✓

For: METHOD OF MANUFACTURING A THIN FILM TRANSISTOR

AMENDMENT

do not  
enter up  
8/14/02  
Commissioner of Patents  
Washington, D.C. 20231

Dear Sir:

RECEIVED  
JUL - 9 2002  
TECHNOLOGY CENTER 2800

In response to the Examiner's Final Office Action dated April 18, 2002, the following amendments and remarks are respectfully submitted.

IN THE DRAWINGS:

Please amend the drawings as shown in red in the attached Request for Examiner's Approval of Drawing Changes.

IN THE SPECIFICATION:

Please amend the specification as follows (A Marked-Up Version of the Amended Specification is attached):

On page 2, Paragraph beginning on line 13:

Fig. 1 is a cross sectional view illustrating a typical AM-LCD device. As shown in Fig. 1, the LCD device 20 includes lower and upper substrates 1 and 3, with a liquid crystal